

Exploiting Recent Advances in Cavity Surface and Materials Research Toward a 1 TeV ILC Upgrade

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Acknowledgments:

M. Champion, C. Cooper, C. Ginsburg, R. Kephart, J. Kerby,
T. Prolier, C. Reece, A. Romanenko, A. Rowe, J. Zasadzinski

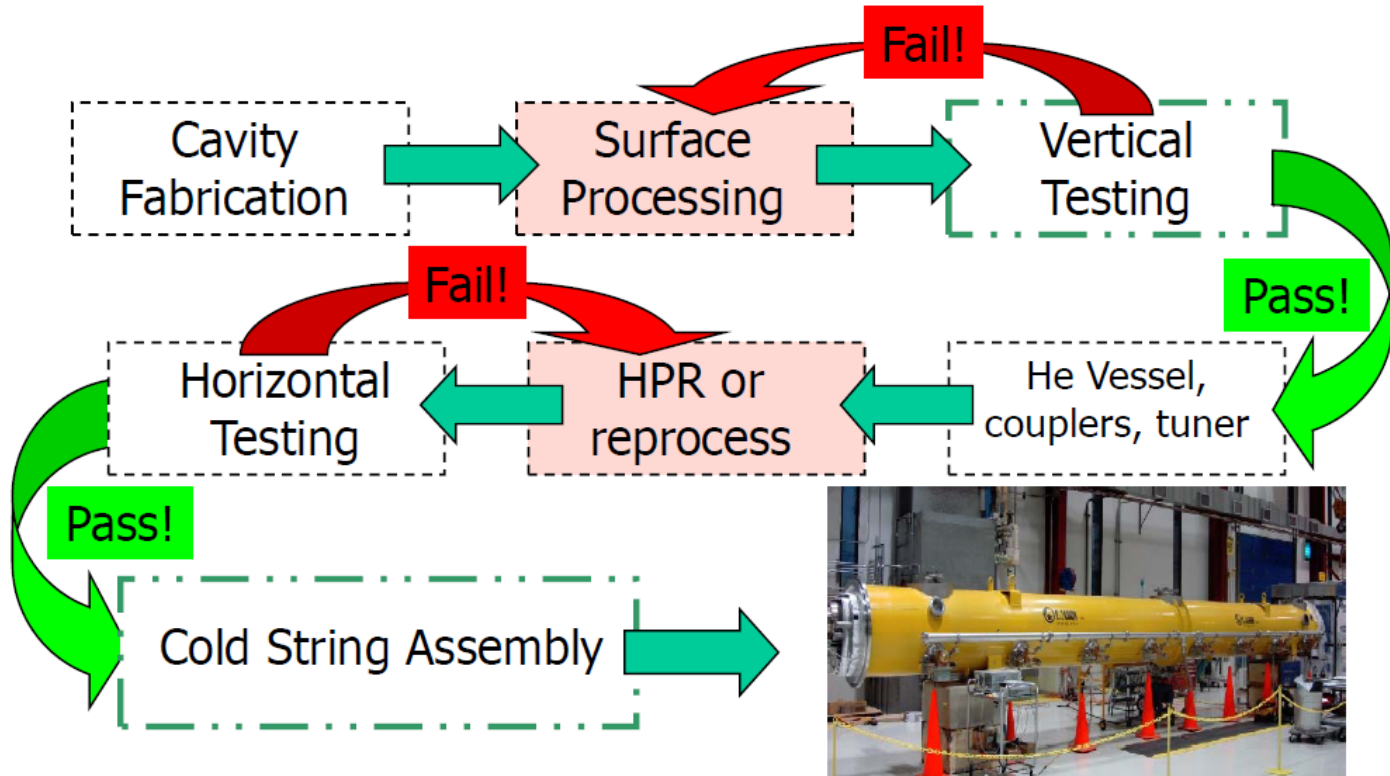
Charge and Context

- Consider long-term (10 year) SCRF cavity R&D toward a Main Linac upgrade to 1 TeV
 - What approaches are technically possible?
 - Looking forward, what long-term efforts should be integrated with the present R&D effort?
- Improvement by factors of 2 or even 10
 - Higher gradient and higher Q
 - Simplify, reduce cost, increase yield
 - Reduce hazards, lessen environmental impact

The present ILC industrialization plan

R. Kephart, 2010 SCRF Cavity Technol. & Industrialization Wkshp. / Kyoto

Cavity/CM process and Testing

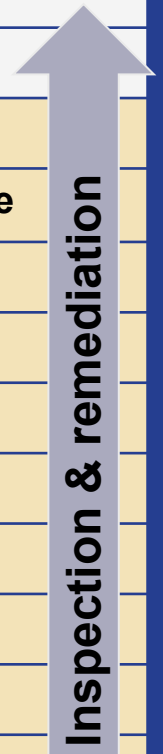
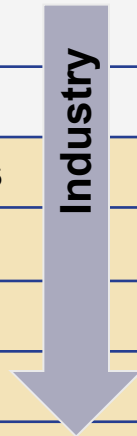


Plan... Develop in labs then transfer technology to industry

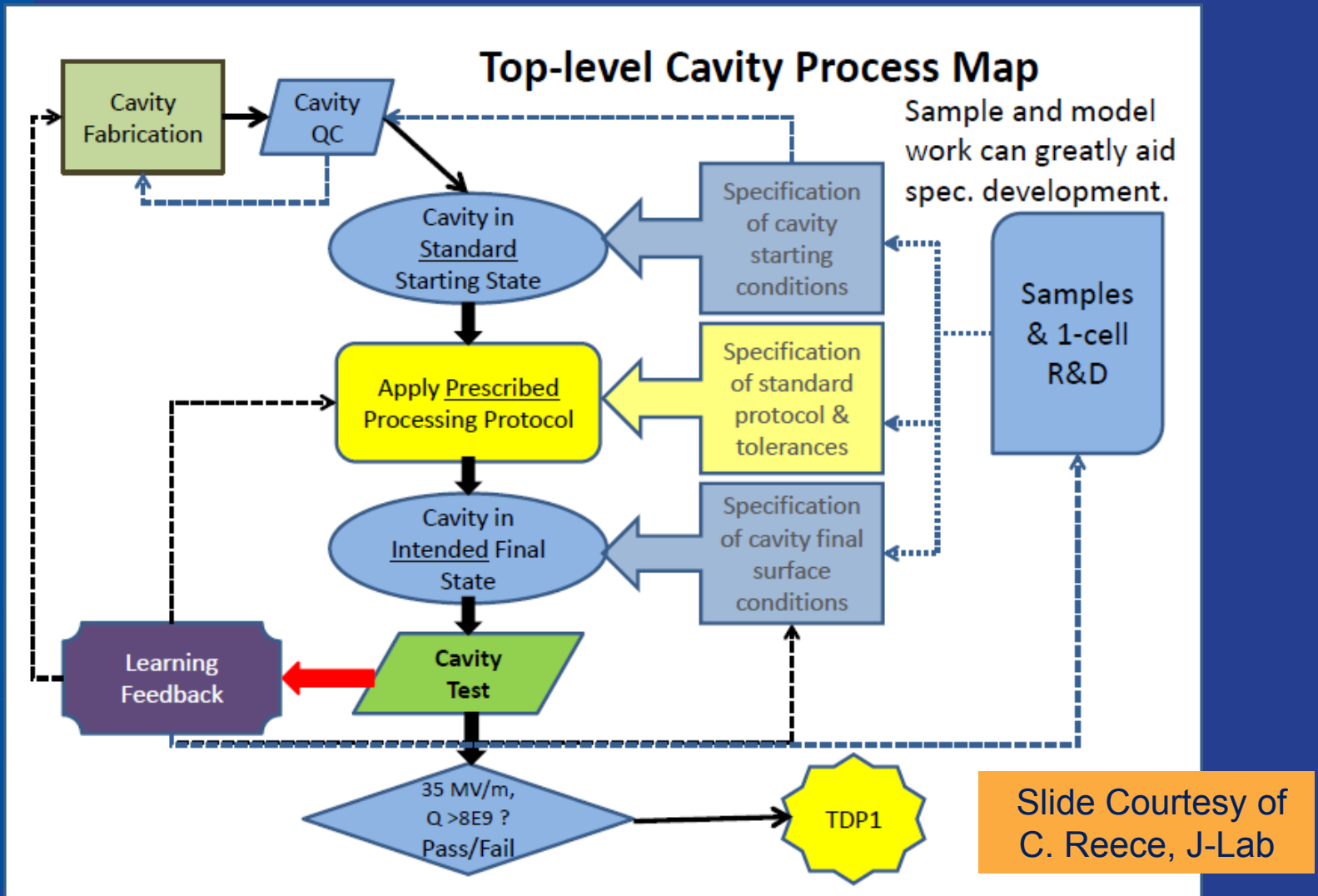
The present ILC processing baseline

J. Kerby for the S0 Team, 2010 SCRF Cavity Technol. & Industrialization Wkshp. / Kyoto

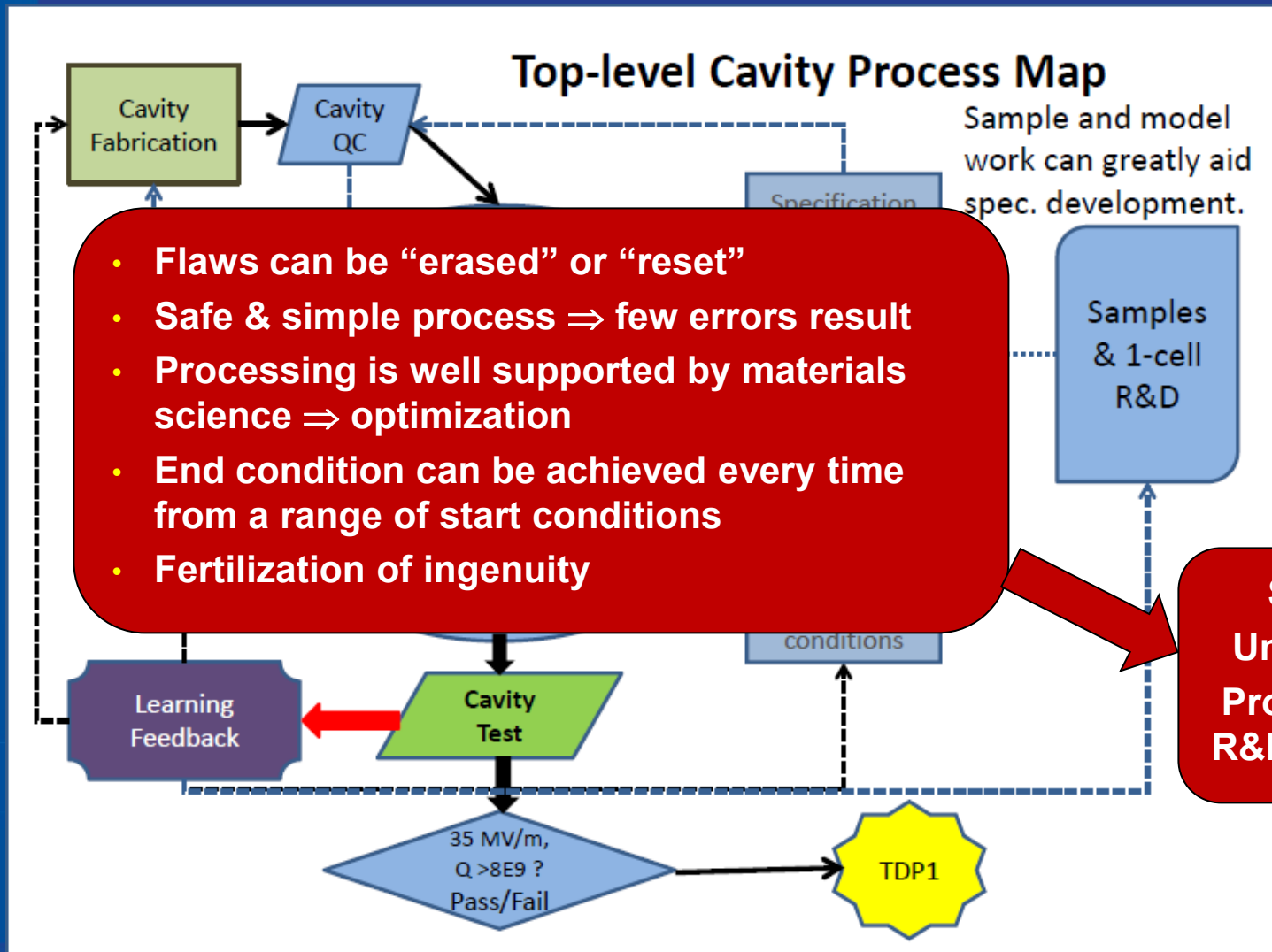
	Standard Cavity Recipe
Fabrication	Nb-sheet (Fine Grain)
	Component preparation
	Cavity assembly w/ EBW
Process	BCP + 1 st (Bulk) Electro-polishing (>120um)
	Ultrasonic degreasing with detergent, or ethanol rinse
	High-pressure pure-water rinsing
	Hydrogen degassing at > 600 C
	Field flatness tuning
	2nd Electro-polishing (~20um)
	Ultrasonic degreasing or ethanol rinse
	High-pressure pure-water rinsing
	Antenna Assembly
	Baking at 120 C
Vertical Test	Performance Test with temperature and mode measurement → inspection, reprocessing, other remediation



Pathway #1: Proscriptive extensions of the present baseline (next presentations)



Pathway #2: Alternate processes that are more forgiving, adaptable, simpler, cheaper

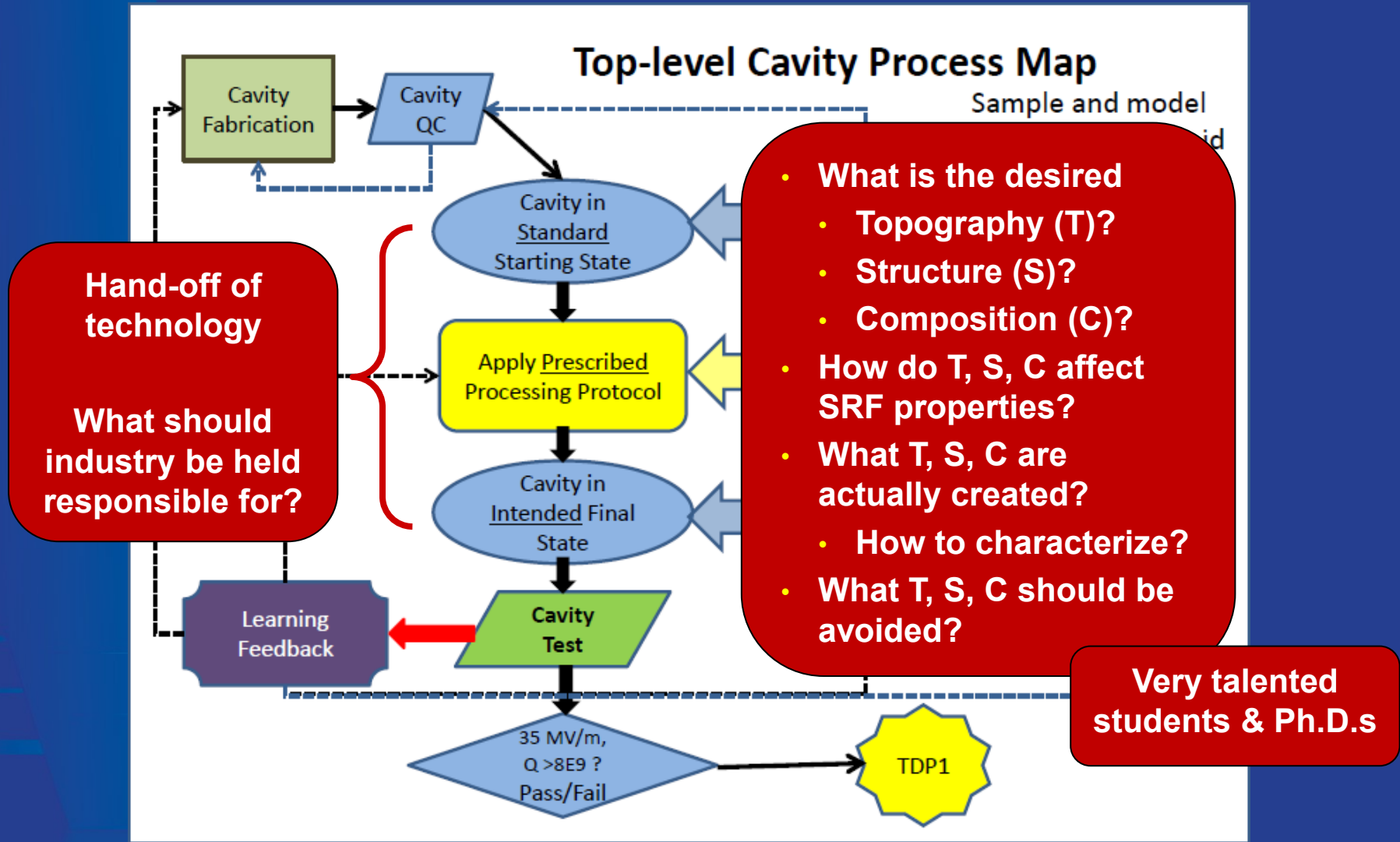


Promising Alternate Processes

- Cavity Hydroforming and Nb Tube R&D
 - Must support both areas in a coordinated program
- Extended CBP / tumbling / mechanical polishing
 - Transformational — Very smooth surfaces, forgives / repairs flaws, low-tech, eco-friendly
 - Can the process be completely free from toxic acids?
 - Adapt polishing to other cavity shapes?
- Alternatives to HPR
 - E.g. Peel-off coatings used to clean telescope mirrors
- High-power deposition of films
 - Recent breakthroughs bring RRR up above 300
- End group manufacturing
 - Can this be done as a solid piece? With simple welds?

Guidance comes from physics and materials science

Top-level Cavity Process Map



R&D opportunities motivated by physics & materials science

- Dry cleaning techniques, e.g. plasma cleaning
 - Apply just after 800 °C bake
 - Integrate cleaning station with regular processing
- Protective coatings & Hydrogen barriers
 - Develop an atomic layer deposition process that integrates with regular cavity processing
- Not discussed here: multilayers, other materials
 - These may naturally evolve from films and coatings
 - Long pathway toward an engineering form

Characterization R&D

- Wider use of grain orientation imaging
 - How does texture affect processing?
 - Proscribed textures
 - Textures tolerant of processing variations
- Methods to map field emitter locations
 - Are emitters always the result of a process flaw, or are some due to materials?
 - **Grand challenge – Only nascent R&D ideas at present!**
- Coupon Cavities
 - Permits rapid processing feedback

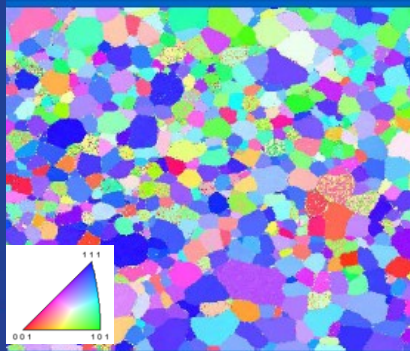
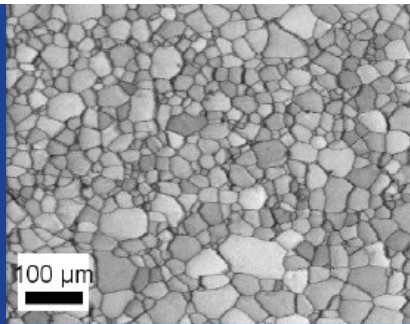
PROMISING ALTERNATE PROCESSING ROUTES

Hydroforming

- DESY has proven the principle with 3x3 cavities
 - Several review presentations by Waldemar Singer
- Extensive exploration by J-Lab & KEK, too
- Tube technology has emerged, is now ready
 - ATI Wah Chang now sells 150 mm x 1.5 m x 4 mm wall fine-grained seamless tubes (see next slide)
 - Billet process integrated with extrusion & forming
- FNAL has an active RFP with ILC-ART funding
 - Motivation: Reduce welds and weld defects
 - Goal: complete 9-cell hydroformed cavities
 - Workshop on 1 Sept. 2010, several vendors interested
 - 9-cell cavities hoped for by September, 2012
 - **Need end group R&D**

Successful DOE-SBIR with follow-on:
 Black Labs / Dynamic Flow Forming / ATI Wah Chang / J-Lab / FNAL

13 μm grains
 Random orientation



R. Crooks et al.
 Billet forging +
 back extrude +
 flow form



DOE SBIR DE-FG02-04ER83909

6" I.D. RRR
 Tubes at
 ATI Wah Chang

As flow-formed

For DESY
 Hydroforming
 Machine Size

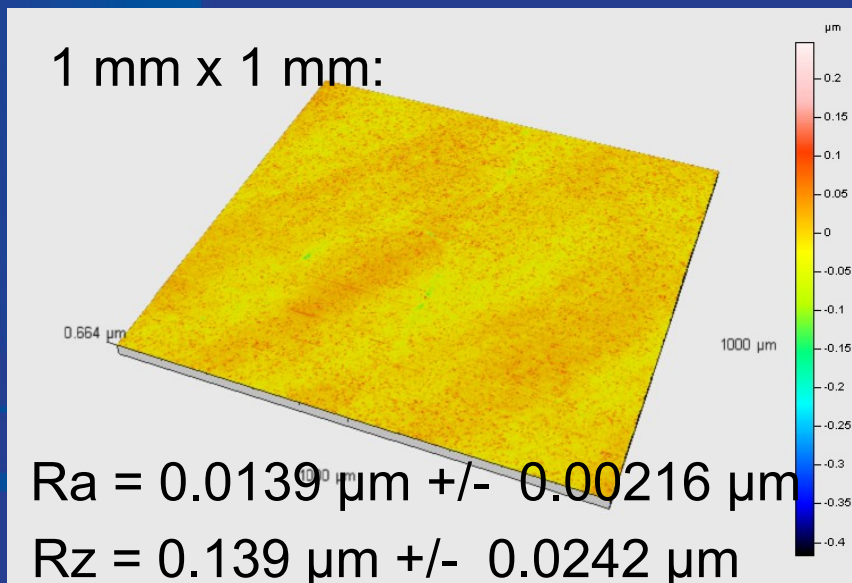
1.65 m length
 ~ 3 mm wall

Niobium tube R&D

- Labs have ability to image grain orientations now
 - Very powerful at debugging raw material (e.g. tubes)
 - **R&D: do grain orientations affect downstream processing?**
- Reprocessing ideas
 - Texas A&M / Shear Form: Grain refinement, texture control, and weld healing by equal channel angular processing (SBIR)
 - Does not reduce diameter of tube while refining grains
 - **Can cheaper tubes with inferior microstructures be tailored for hydroforming?**
 - Nev.-Reno / Mich. State / Wah Chang: Zone induction annealing
 - **Can reactor grade tubes be refined to RRR grade?**
 - **Single crystal tubes have been demonstrated**
- **Long term: are re-entrant hydroformed cavities possible?**

Tumbling / Extended CBP

- Order-of-magnitude improvement in surface finish over EP
 - By a tech in a lab coat & safety glasses working in typical lab space.
- Thanks to pioneering work by Higuchi, Saito, Singer, others
 - Many groups already have a machine !
 - Assuredly, many exciting innovations are still to come



Courtesy C. Cooper, TTC Milan slides



Extending CBP* to fine polishing

Step 1 Cutting



+ Soap
& Water

Step 2 Intermediate Polishing



+ Soap
& Water

Step 3 Intermediate Polishing



400 grit
Alumina
+ Water
(~20 μm)

Step 4 Intermediate Polishing



800 grit
Alumina
+ Water
(~10 μm)

Step 5 Final Polishing



Colloidal
Silica
(0.05 μm)

CBP

Cooper's key observation: must soak the
hardwood blocks in the slurry†

*Higuchi T et al., 1995 Proc. 7th Wkshp RF Supercond. (Saclay, Gif sur Yvette, France) p. 723.

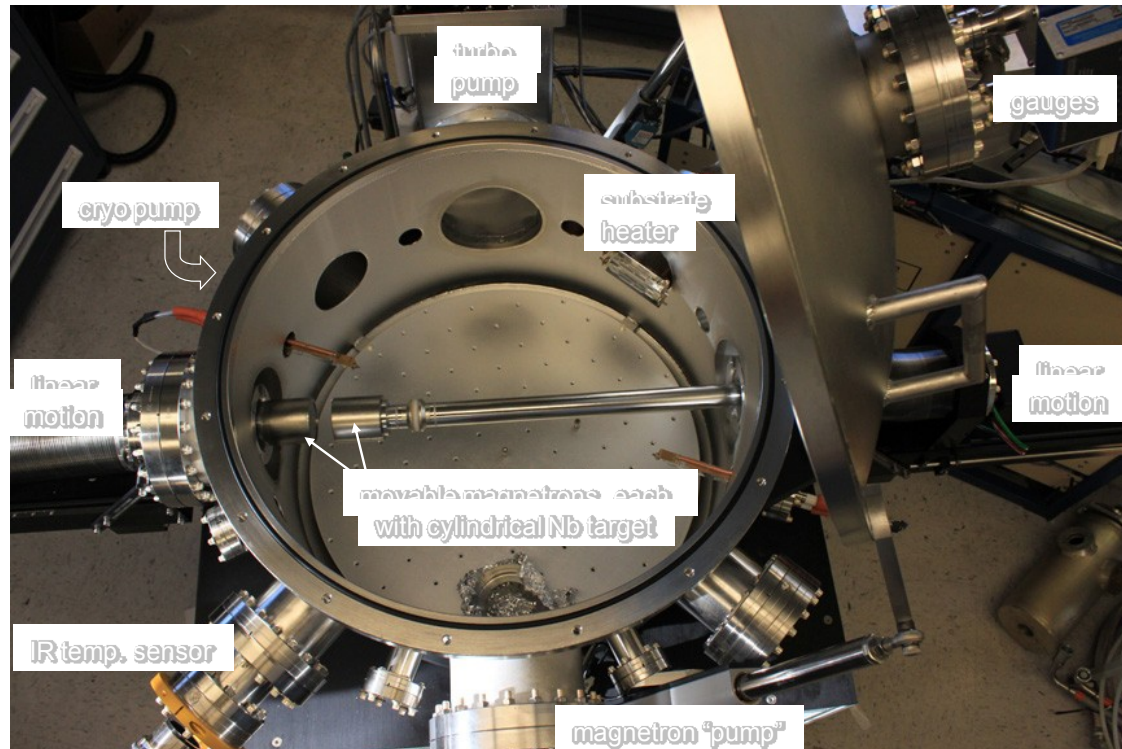
†Cooper C and Cooley L, Superconductor Science and Technology, submitted

Comments on tumbling

- Mirror smooth after step 5, best Q(E) after step 4 with final EP (so far – see Cooper’s TTC slides)
 - Smearing traps media at $\sim 10\ \mu\text{m}$ scale when stage 5 is not applied long enough, just like coupon metallography
- More hydrogen – longer bake at $800\ \text{°C}$ needed
 - Bake to $p(\text{H}_2)$ and $p(\text{H}_2\text{O})$ standards?
- Parallel and scalable, few control “knobs”
- Can toxic acid be avoided completely?
- Does tumbling encourage re-entrant cavity R&D?
- Long term: Does step 5 enable an entirely new cavity paradigm where the RF surfaces are constructed from films and coatings on cheap Cu?

High power impulse magnetron sputtering

**A state-of-the-art HIPIMS system for 1.3 GHz,
Offering optional dual-HIPIMS and two-material HIPIMS**

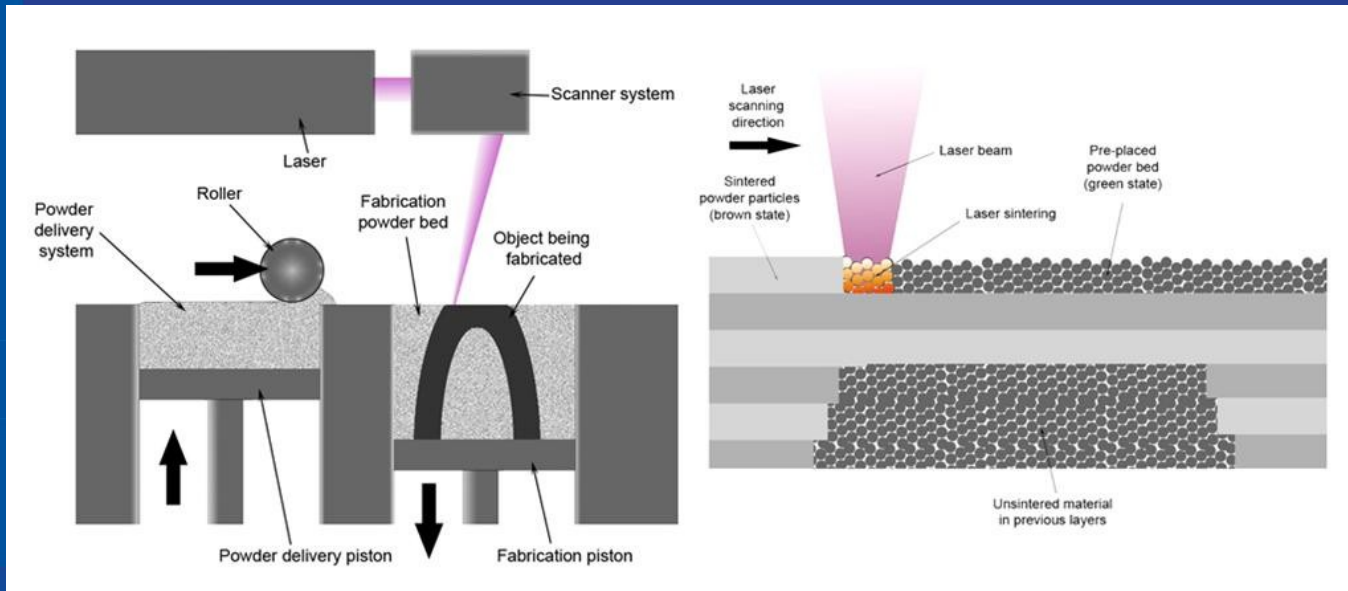


A. Anders, J. Vac. Sci. Technol. A 28 (2010) 783

- Zhou (J-Lab), with Alameda Applied Sciences: Nb films with RRR well above 300 attained for first time, Oct 2010
 - Flat films on hot sapphire
- Anders (LBL): HiPIMS system ready for cavities
- Do the new breakthroughs make Nb/Cu or Nb/Al work for ILC?

Single-piece end groups

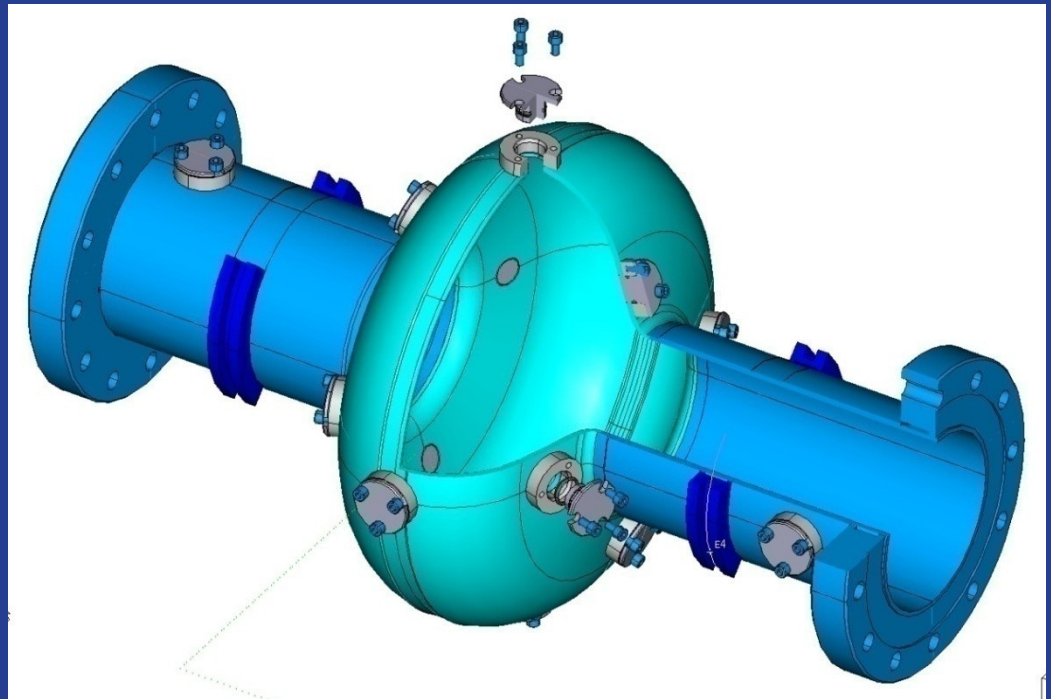
- India collaboration and Niowave have explored ideas to machine end group from Niobium blocks
- Additive machining – 3D “printing” from metal powders in vacuum, followed by sintering
 - Well established for complex titanium pieces
 - Niobium’s challenges (high m.p., clean) could be met due to recent advances in equipment



All Labs should use coupon cavities

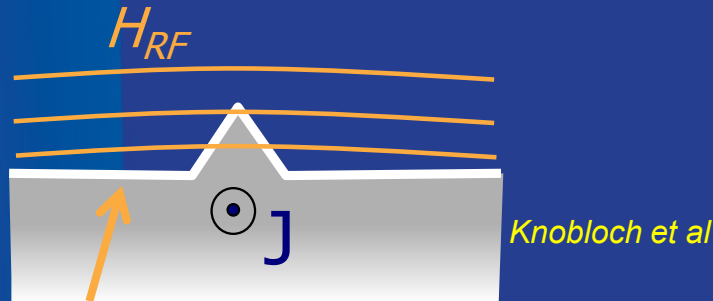
- Give materials scientists opportunities to provide process feedback without dissecting cavities
 - No other way to obtain spectroscopy from inside cavity
- Is a thick-wall version possible ?

C Cooper's design,
similar to several others
already being used

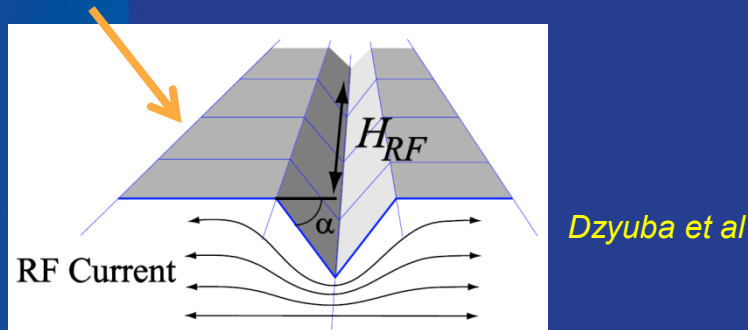


R&D MOTIVATED BY PHYSICS AND MATERIALS SCIENCE

General aspects of the SRF surface



Surface Barrier

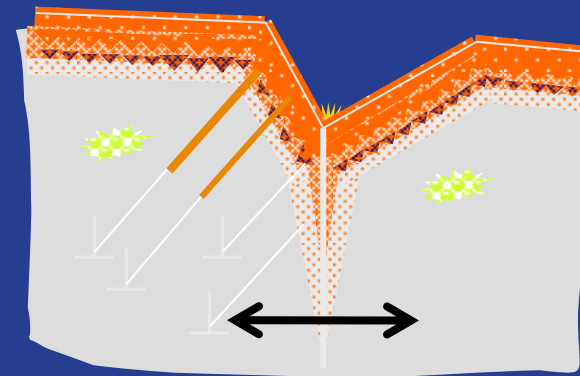


RF flux should not penetrate due to topography: **Smoothen surfaces are better** (but how smooth is smooth enough?)

High H_c
low κ

Lower H_c
higher κ
??

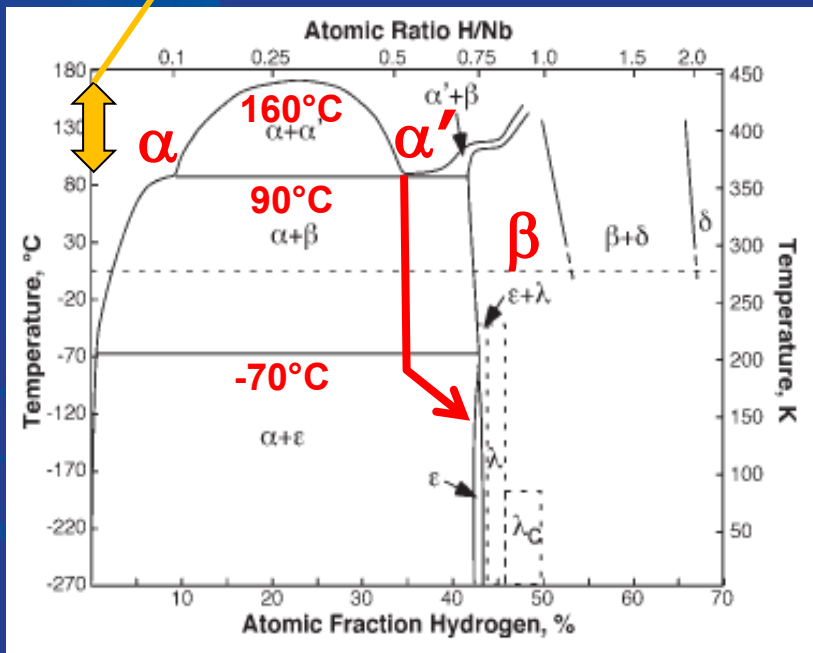
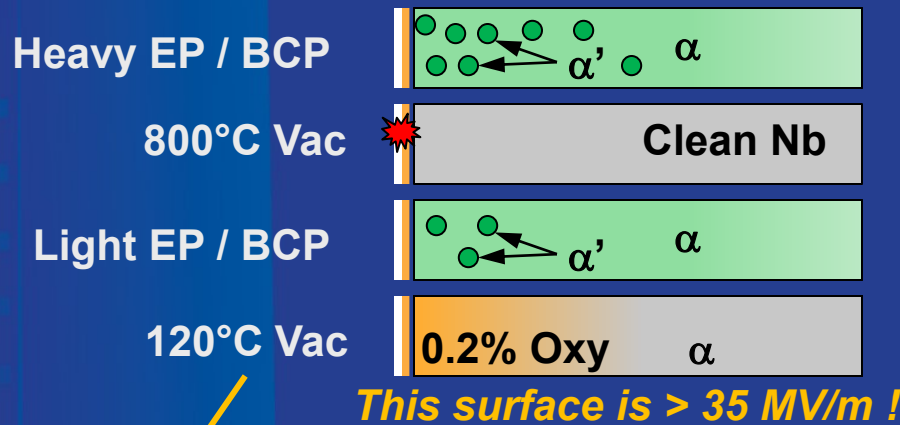
Base superconducting properties should be ideal: **Less contamination**



*Halbritter,
Antoine, et al,
Tian et al,
Many others*

RF current should not be induced across non- or weakly superconducting boundaries, precipitates, defects and damage: **Less contamination**

Latest models of the Nb surface region



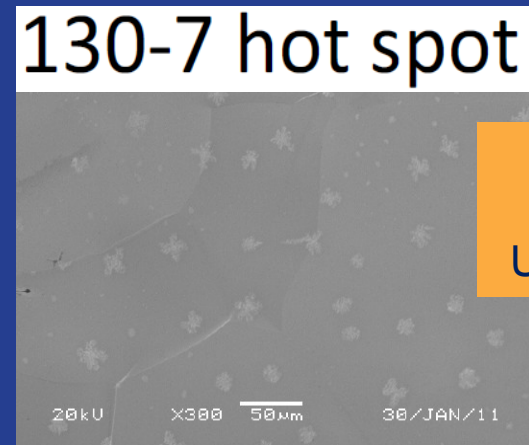
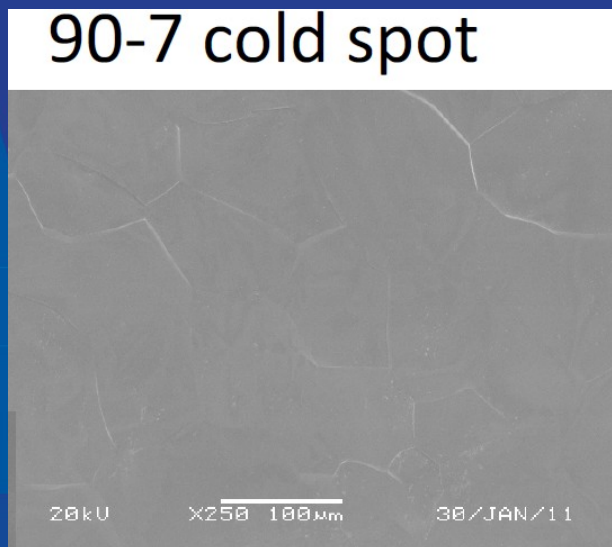
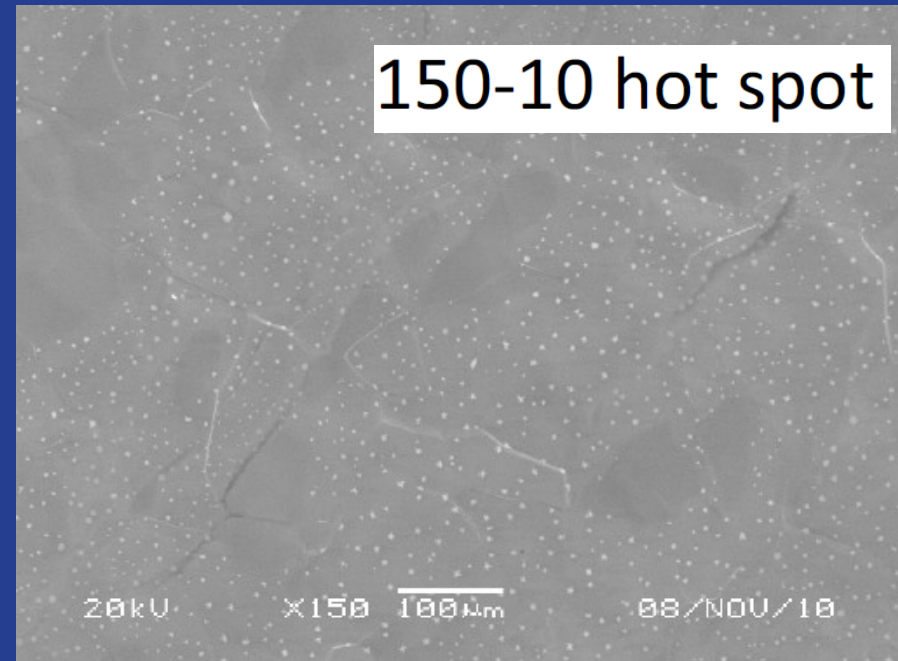
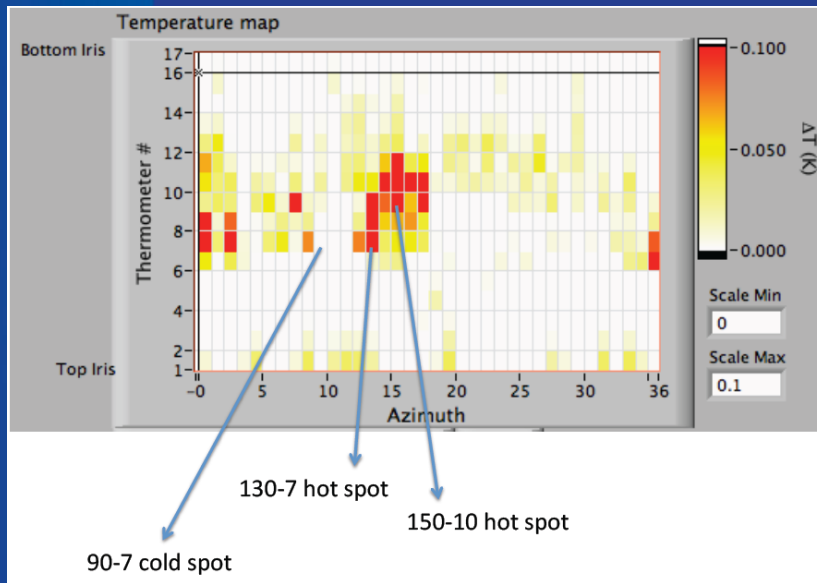
- 10-40% H at / under surface
 - BCP, EP, warm water ...
 - $\alpha' \rightarrow \beta$
 - Nucleation on defects
 - What change after 800°C bake is more important: reduction of H or removed nucleation sites?
- Lots of β : Q sickness
- Some β : Q slope?
 - Are mid- and high-field Q slopes different aspects of same nanostructure?

Ricker Myneni J.Res.NIST 2010

Ciovati – Ingot niobium workshop at J-Lab Sept 2010

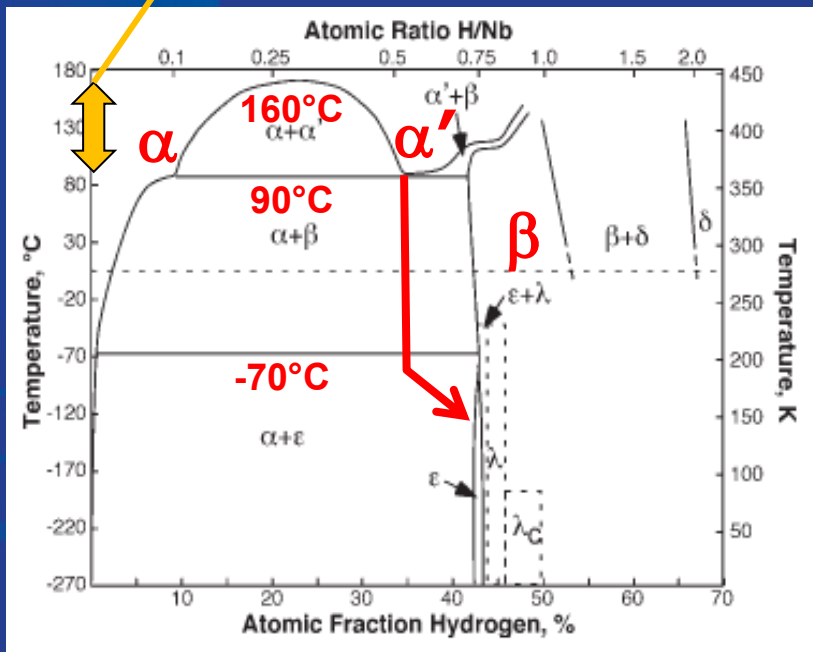
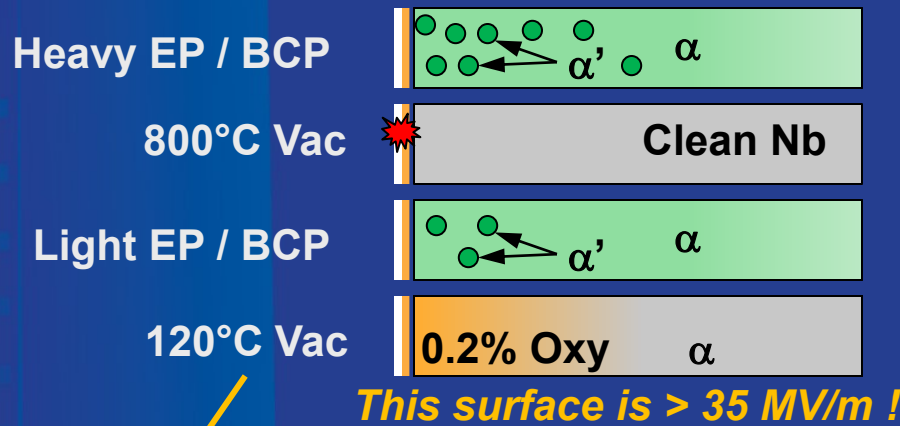
Romanenko - He atom recoil spectroscopy with U.Mich. & W.Ontario

Possible connection between Q-slope (onset above 100 mT) and small near-surface precipitates



A. Romanenko,
Fermilab,
Unpublished work

Latest models of the Nb surface region



- 90°C to 160°C mobilizes H
 - H clusters (α') disperse from vacancies, defects ¹
 - Oxygen enters from decomposition of surface oxide ²

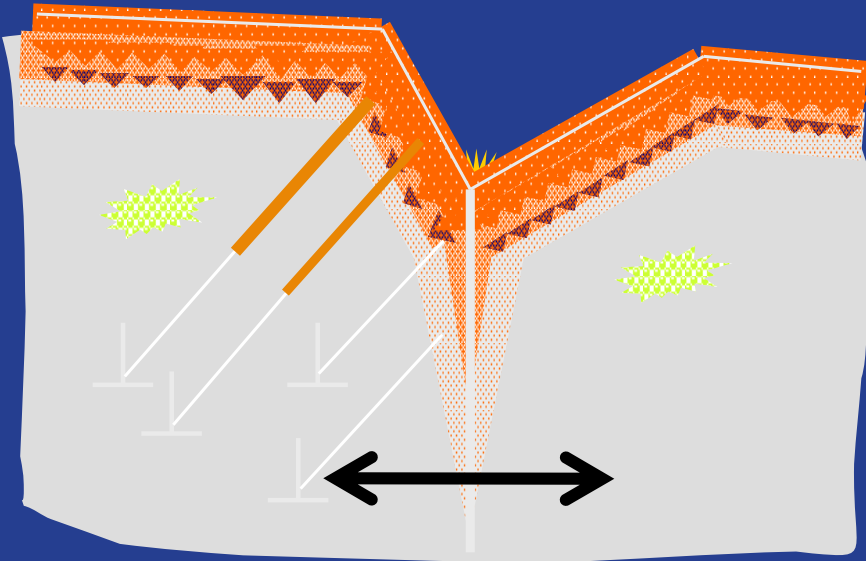
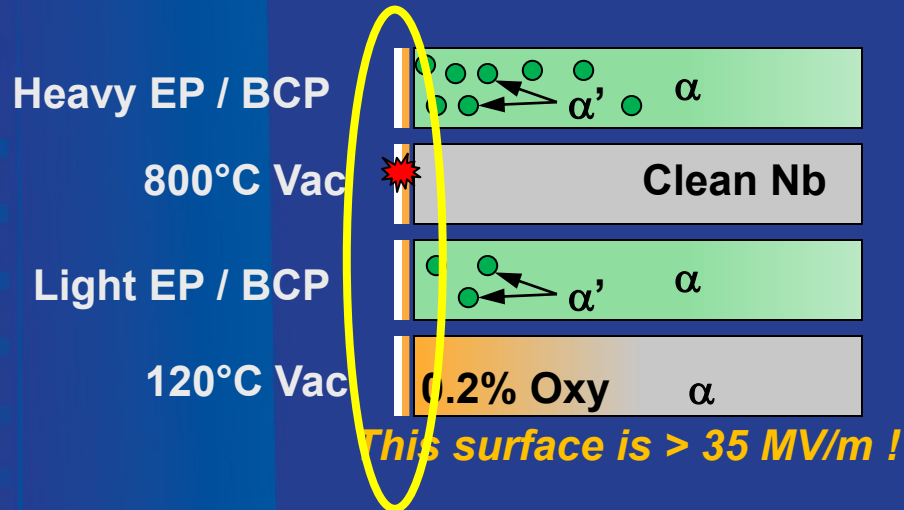
- Does O bind to nucleation sites and disperse H, thereby suppressing β ? ³

[1] Visentin et al, e+ / e- annihilation, SRF2009; Romanenko Ph.D. Thesis – Cornell,

[2] Casalbuoni et al, Nuc.Inst.Meth.PR-A 538, 45 (2005)

[3] D. Ford (NWU Ph.D. student) DFT + VASP at Fermilab

Latest models of the Nb surface region



- Nb-oxides contain magnetic defects^{1,2}
 - Break Cooper pairs, reduce Q
 - Oxides are often amorphous³, full of defects
 - Do dislocations transport magnetic ions inward?
- Are “wet” oxides worse than “dry” oxides?
 - Wet = water vapor, aqueous
 - H stabilizes O defects²

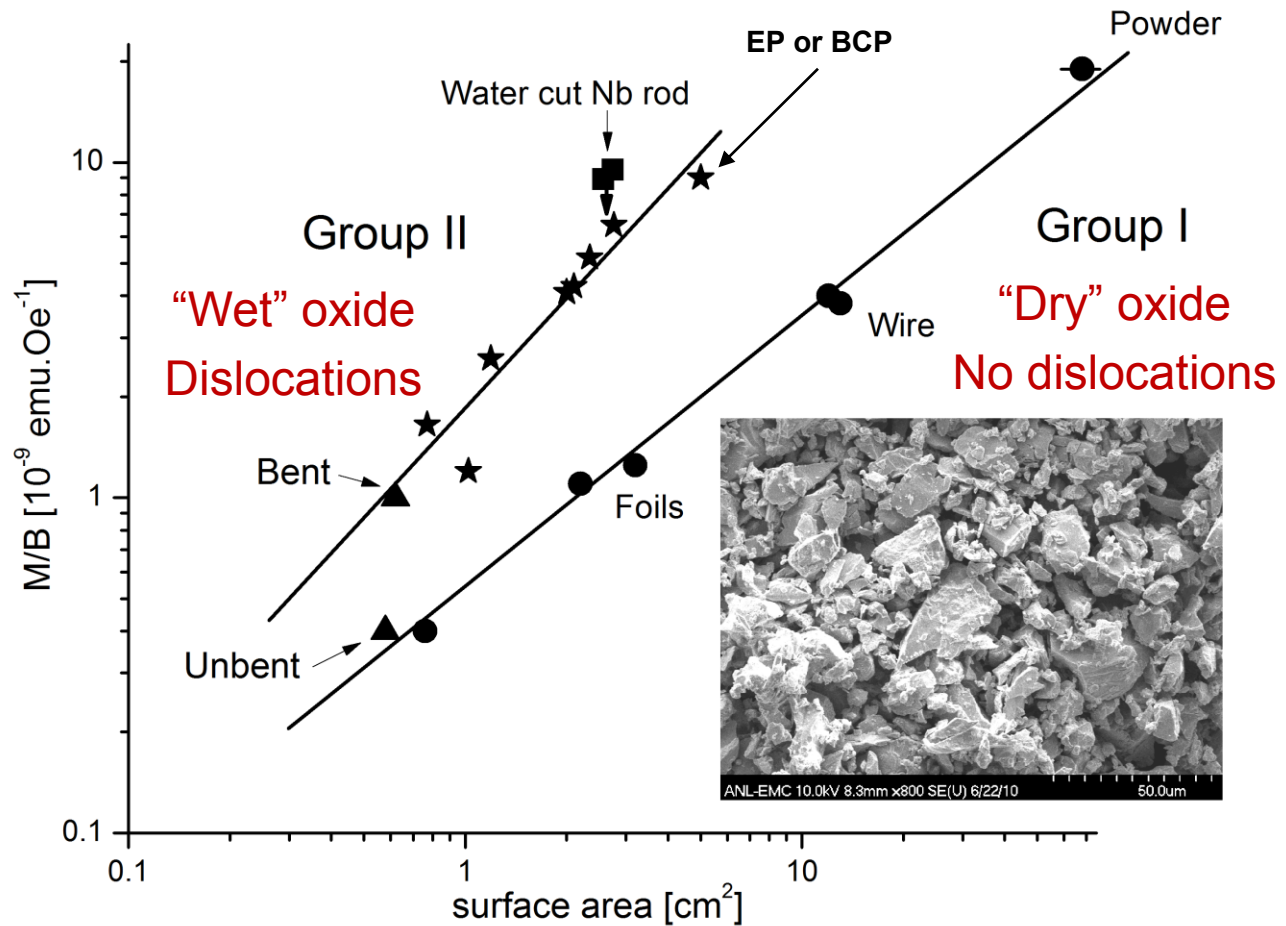
[1] Point-contact tunneling data: Zasadzinski group, IIT, and Prolier group, ANL, Appl. Phys. Lett. 2008, 2009.

[2] Density-functional calculations: W. Walkosz, ANL

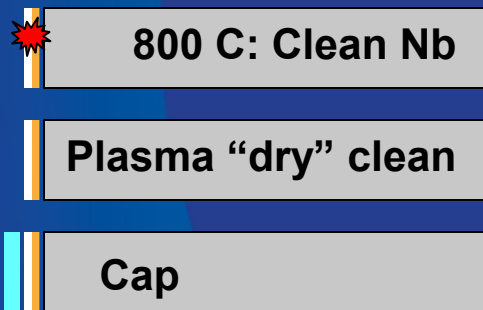
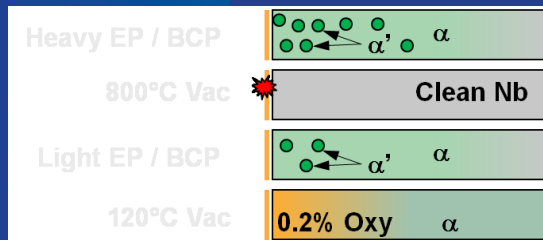
[3] TEM data: R Klie, UIC

Dislocations affect magnetic signature

Slide Courtesy of T. Prolier, ANL and J. Zasadzinski, IIT



Implications for final processing R&D



No need for HPR?

- The 800°C high-vacuum anneal is a very important step
 - It erases side-effects of bulk removal
 - It forgives aspects of forming, welding
 - **Are there better standards than time + temperature?**
- Preserve the metal in this state
 - Low concentrations of O and H
 - Low concentrations of defects, nucleation centers, and dislocations
- Remove any debris by a dry technique, then cap immediately
 - Dry plasma cleaning
 - Dry deposition, e.g. modified ALD

Summary of R&D areas

- 9-cell Hydroforming
- Tubes for hydroforming
 - ATI Wah Chang product
 - Equal channel angular process
 - Zone annealing
- Tumbling
 - 4-step extension of CBP – ready to integrate with present process
 - Jump to mirror-smooth 5th step
 - As preparation for thin films
- Films & coatings
 - High power impulse sputtering
 - Dry etch, e.g. plasma cleaning
 - Dry protective coating, e.g. by Atomic Layer Deposition
 - Peel-off dust removal
- Coupon cavities
- 1-piece end groups

Possible processing baseline in 5 years

Re-entrant (55 MV/m) Cavity Recipe	
Fabrication	Nb tubes (Fine Grain)
	Single-piece end-group preparation
	Hydroform tubes and assemble end groups w/ EBW
Process	4-step Tumbling (Need to remove only ~ 50µm due to texture control)
	Ultrasonic degreasing with detergent, or ethanol rinse
	High-pressure pure-water rinsing
	Field flatness tuning
	Hydrogen degassing at > 800 °C
	Antenna Assembly
	Plasma Cleaning
	Capping by Atomic Layer Deposition
Vertical Test	Performance Test with temperature and mode measurement → inspection, reprocessing, other remediation

